





Application/Control No.	Applicant(s)/Patent under Reexamination
10/760,300	CHEN ET AL.
Examiner	Art Unit
Shantell Portis	2617

SEARCHED					
Class	Subclass	Date	Examiner		
-					

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
	<u> </u>				

SEAR (INCLUDING S	CH NOTI)
		DATE	EXMR
See Attached		7/27/2006	SLP
		,	
1			